



Patent Application 10/822,960

IFW
Docket No. 24061.187 (2003-1398)
Customer No. 42717

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Pey-Yuan Lee
Serial No.: 10/822,960
Filed: April 13, 2004
For: Carryover Reduction in Multiple
CDSEM Line Matching

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Docket No.: 24061.187
(2003-1398)
Examiner: Andy Huynh
Art Unit: 2818
Conf. No.: 3594

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Mail Stop: Amendment
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present paper is being submitted in response to the Restriction Requirement Office Action dated June 21, 2005 in the above-identified application.

Election of Claims begins on page 2 of this paper.

Amendments to the Claims are reflected in the Listing of Claims which begins on page 3 of this paper.

Remarks begin on page 7 of this paper.

I. Election

In the Office Action mailed June 21, 2005, the Examiner alleges that the application contains claims directed to two inventions and, thus, required restriction of either:

Group I: Claims 1-9, drawn to a method of manufacturing a microelectronic device;

Group II: Claims 10-13, drawn to a method of calibrating a metrology tool;

Group III: Claims 14-16, 21 and 22, drawn to a device; and

Group IV: Claims 17-20, drawn to a method of manufacturing a calibration wafer.

In response, Applicants hereby elect Group I, corresponding to claims 1-9. Applicants' election is made with traverse on the grounds that the embodiments delineated by the Examiner are not patentably distinct and therefore constitute a single invention concept.